

# Evaluation of Compton recoil electron tracking capability of fine-pitch pixel silicon detector with a Monte Carlo simulation

○Mizuki Uenomachi<sup>1</sup>, Kenji Shimazoe<sup>2</sup>

<sup>1</sup>Kyoto University, <sup>2</sup>The Univ. of Tokyo

2023.09.07

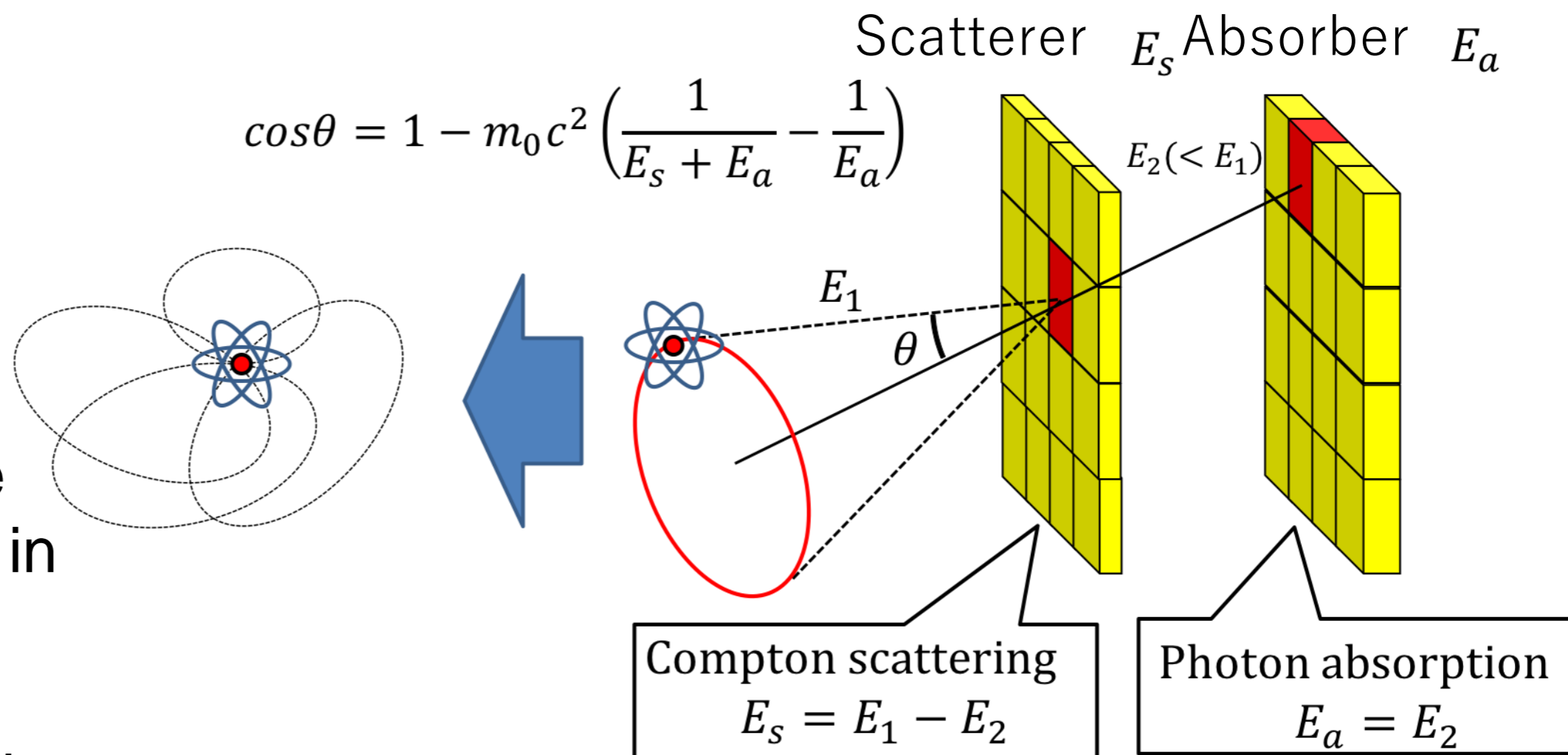


東京大学  
THE UNIVERSITY OF TOKYO



## ◆ Compton imaging

- One of gamma-ray imaging techniques based on **Compton scattering kinematics**
- **Scattering angle information** can be calculated from deposited energies in a scatterer and an absorber
- **No collimators required**
- **Wide photon energy range** for imaging
- **Wide field of view**



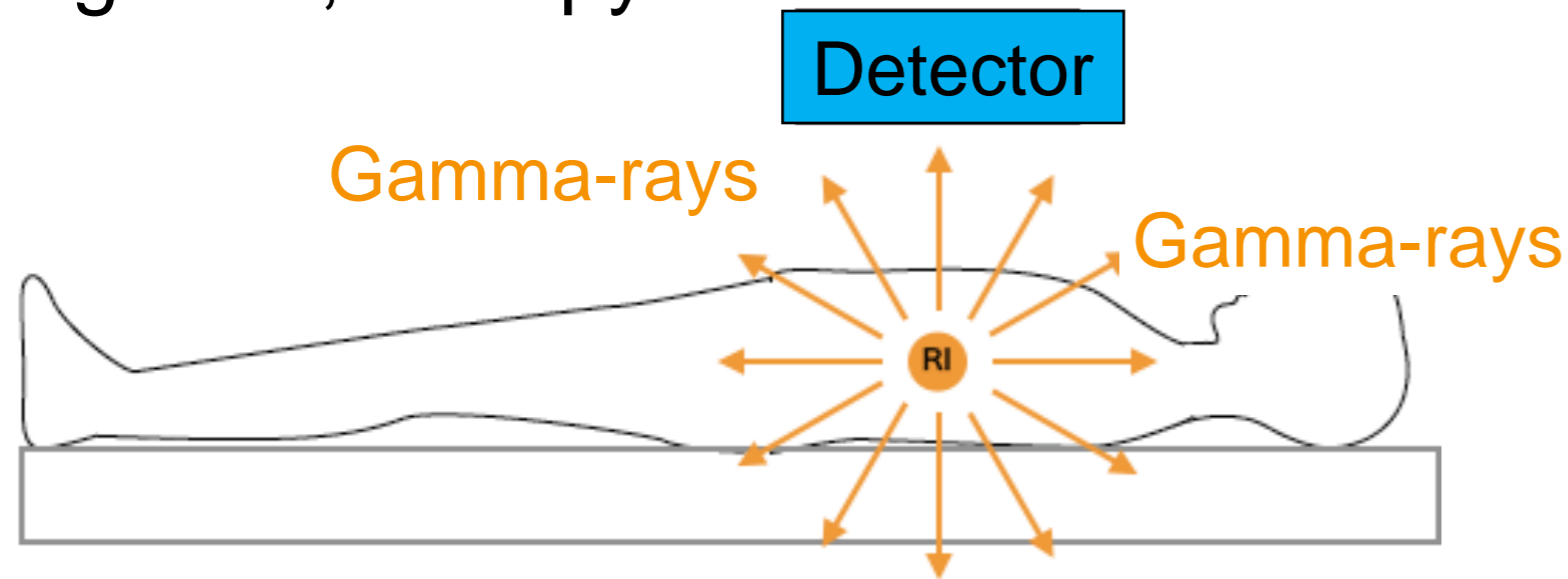
### Application

Astrophysics, Medical field, Nuclear field

## ◆ Compton imaging in medical field

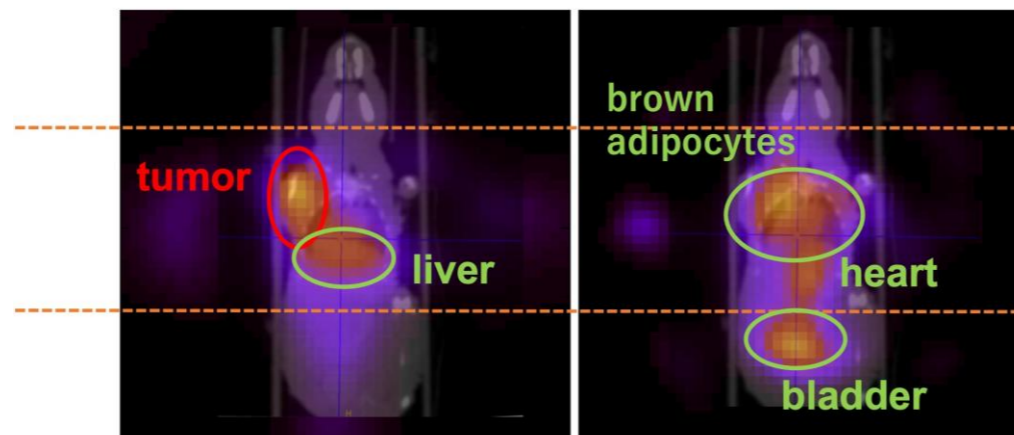
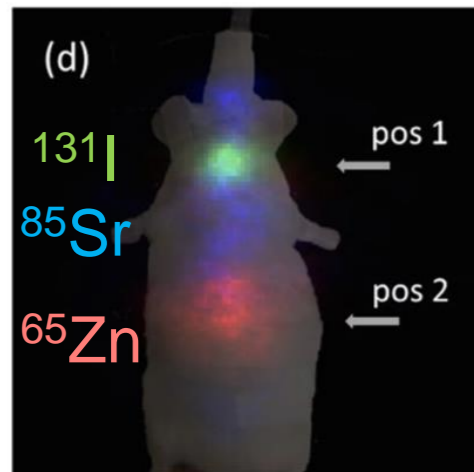
### Nuclear Medicine

→ Diagnosis, therapy



### Radiopharmaceutical accumulation imaging

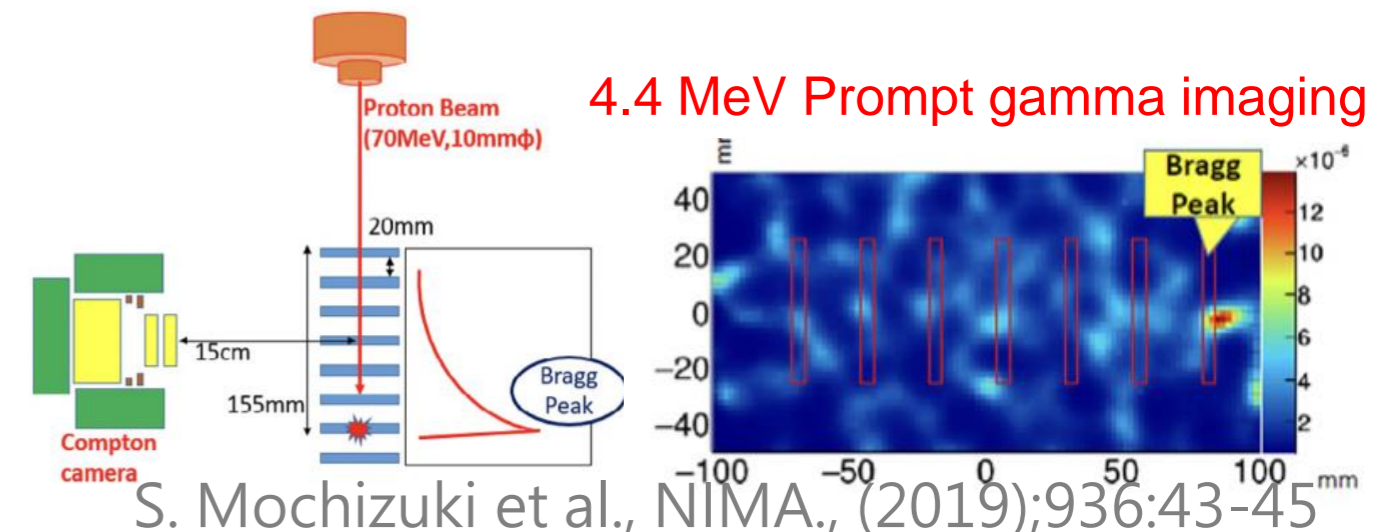
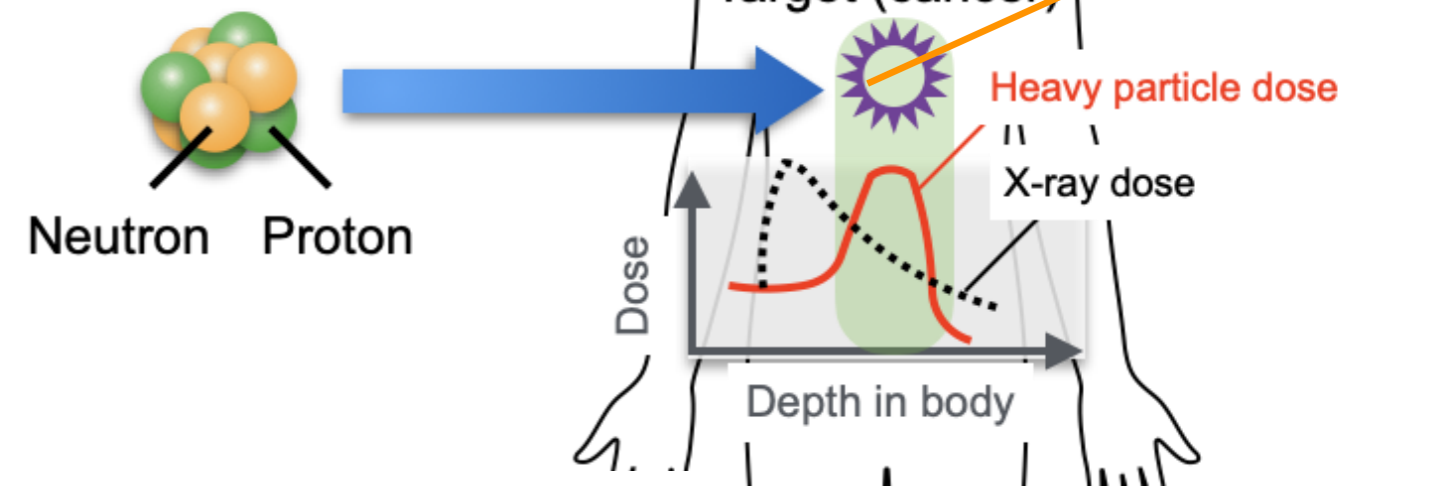
a  $^{111}\text{In}$  Compton imaging    b  $^{18}\text{F}$  Compton imaging



### Heavy particle therapy

#### Prompt gamma-ray imaging

Heavy particle beams





## ◆ Compton imaging in medical field

### Nuclear Medicine

### Heavy particle therapy

→Diagnosis, therapy

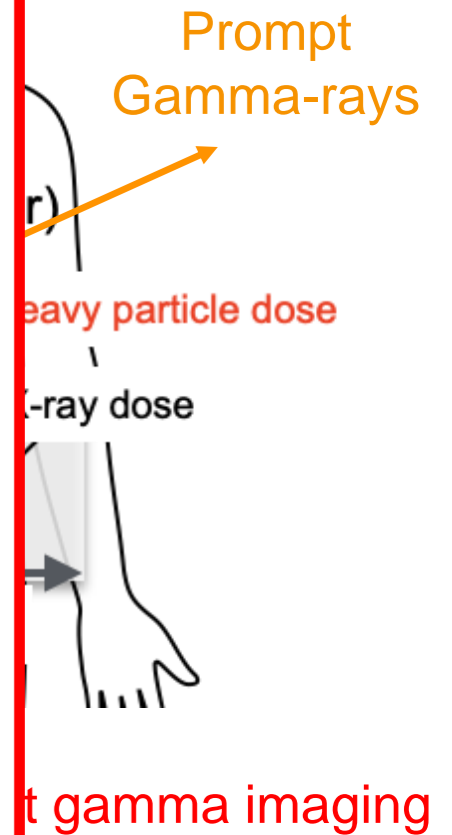
Detector

Prompt gamma-ray

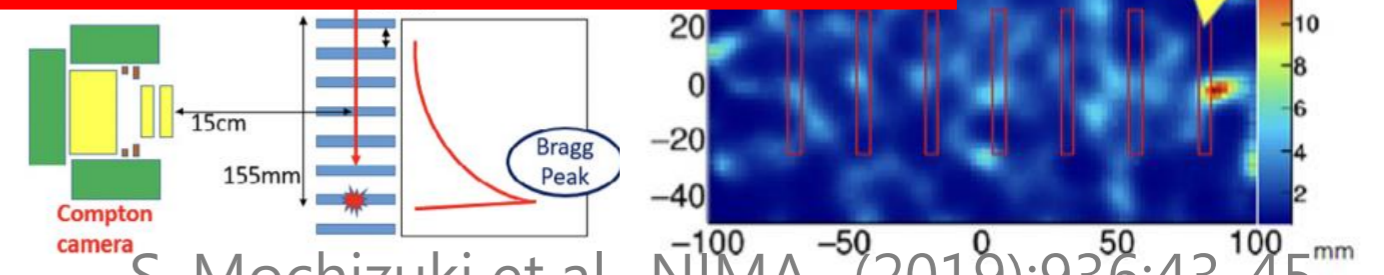
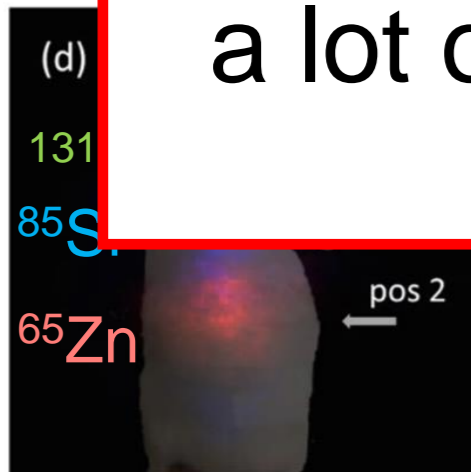


Compton imaging is a promising method in medical field due to the wide energy range and collimator-less imaging

**However, still in under research** because of the **low signal-to-background ration (SBR)** caused by drawing a lot of Compton cones.



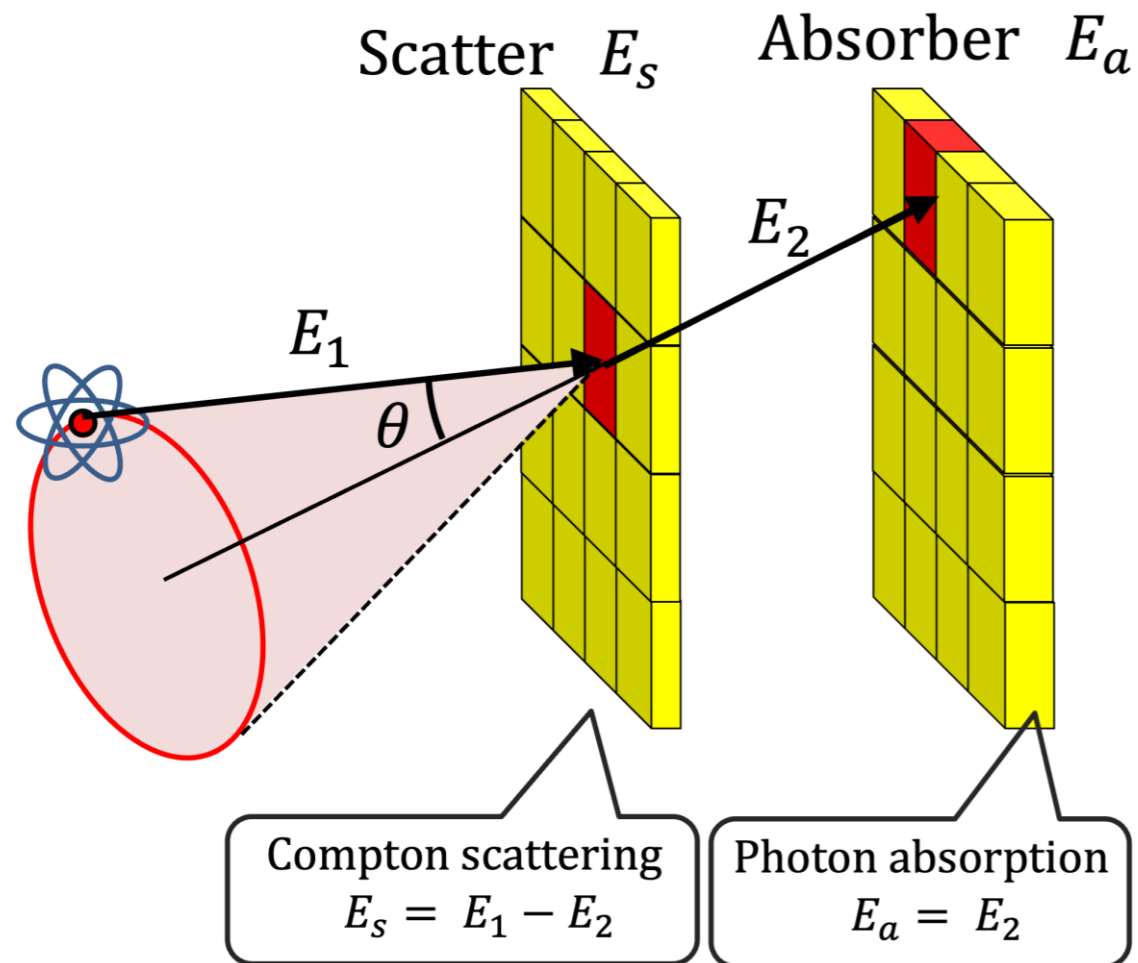
Radiopharmaceuticals



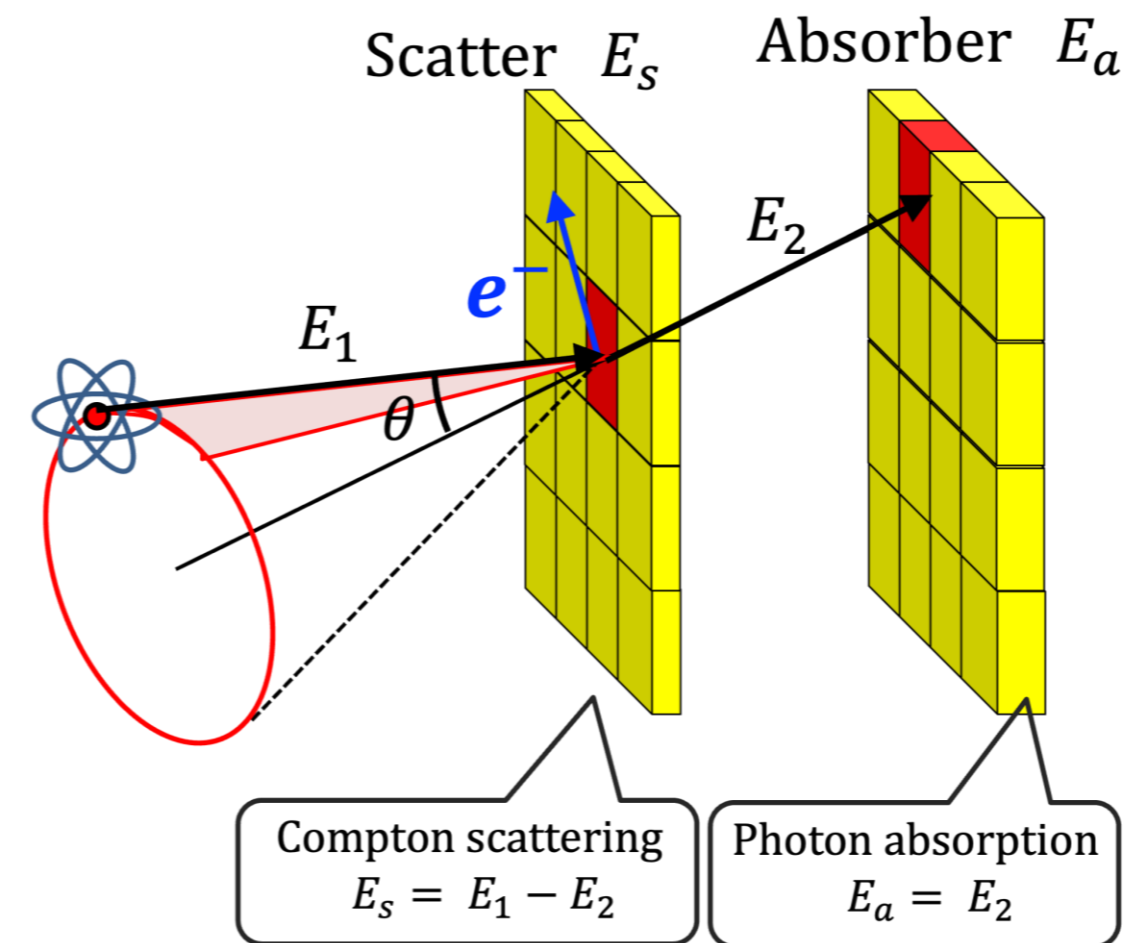
Measurement of a recoil electron trajectory when a photon is Compton scattered in a scatterer

➔ Constrains the radionuclide position on from a Compton conical surface to an arc surface

## Conventional imaging



## Electron tracking imaging



- Electron tracking Compton camera succeeded to be developed with gaseous detectors by Kyoto University Tanimori group for high energy gamma-ray astrophysics.
- For medical imaging, semiconductor detector is ideal
- However, the high spatial resolution (a few tens of  $\mu\text{m}$ ) is required for electron tracking with a semiconductor detector

## Objective

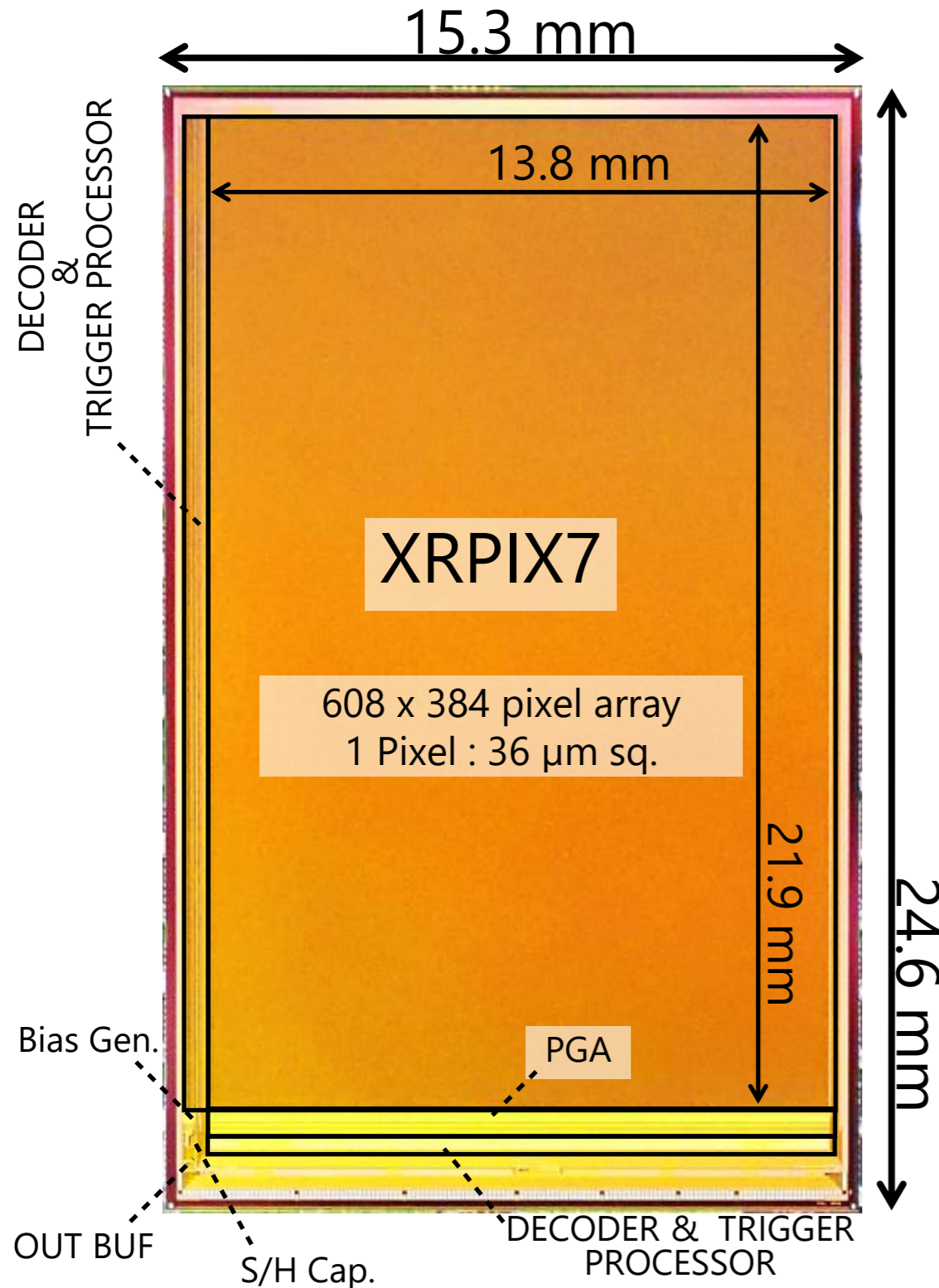
In this study, we developed a **Compton imaging system with SOI (silicon on insulator) fine-pitch pixel sensor and GFAG scintillator detector** for electron tracking Compton imaging



# SOI pixel sensor with 36 $\mu\text{m}$ pixels

Silicon on Insulator (SOI) technique  $\rightarrow$  **Monolithic circuit integrated silicon sensor**

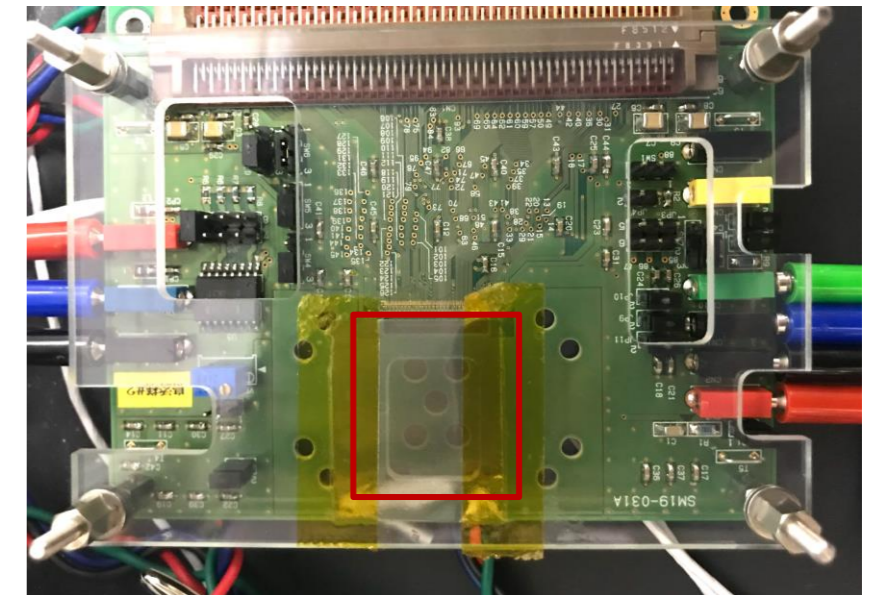
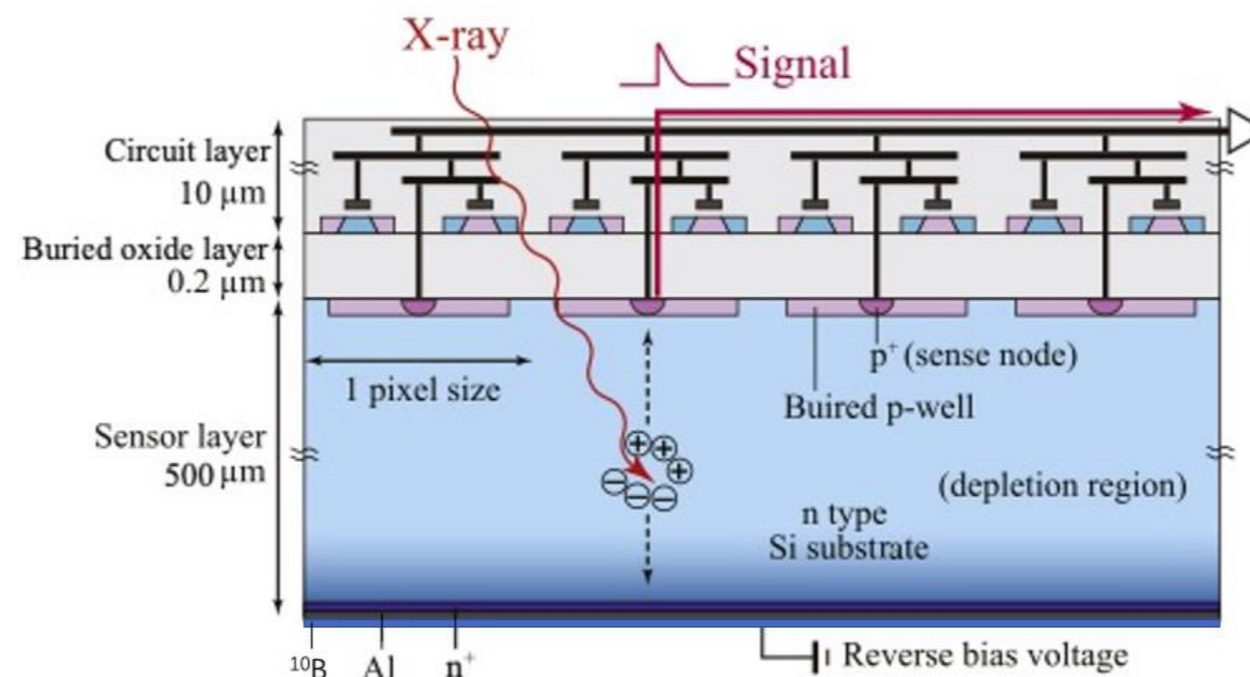
Large area X-ray SOI sensor "XRPIX7"



## Sensor information

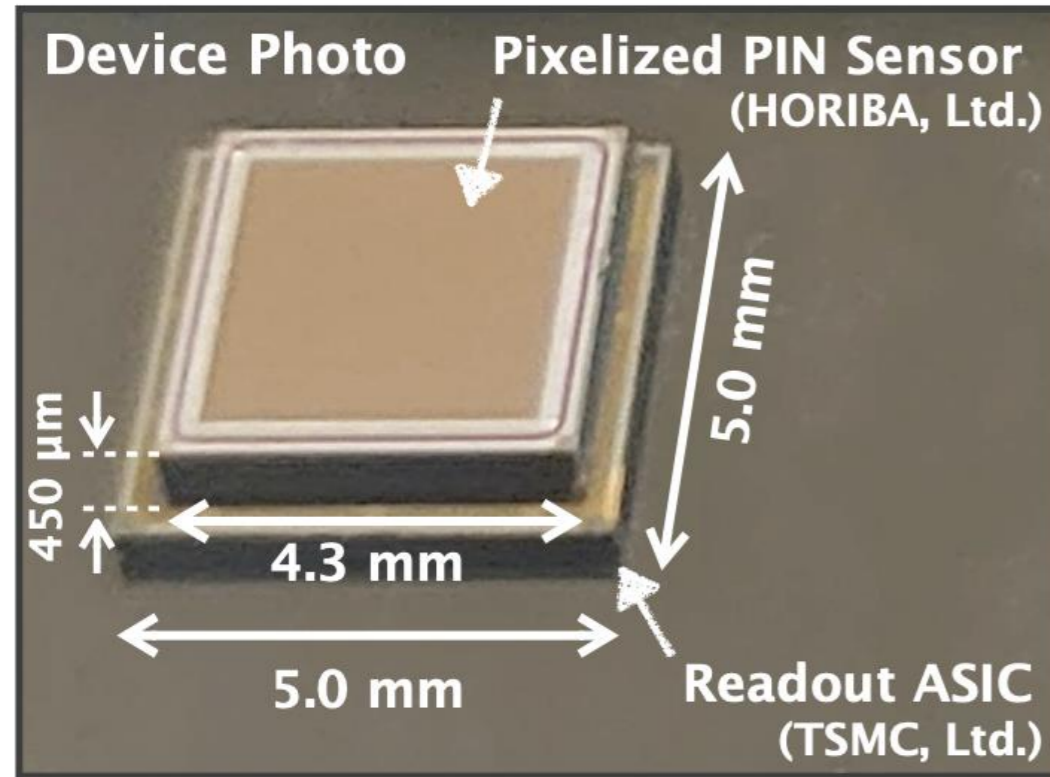
- Chip size: 24.6 mm x 15.3 mm  
(Active area: 21.9 mm x 13.8 mm)
- Pixel size: **36  $\mu\text{m}$  sq.**
- Pixel number: 608 x 384 (= ~233k)
- Sensor thickness: 300  $\mu\text{m}$

**Event driven mode  $\rightarrow$  coincidence detection**



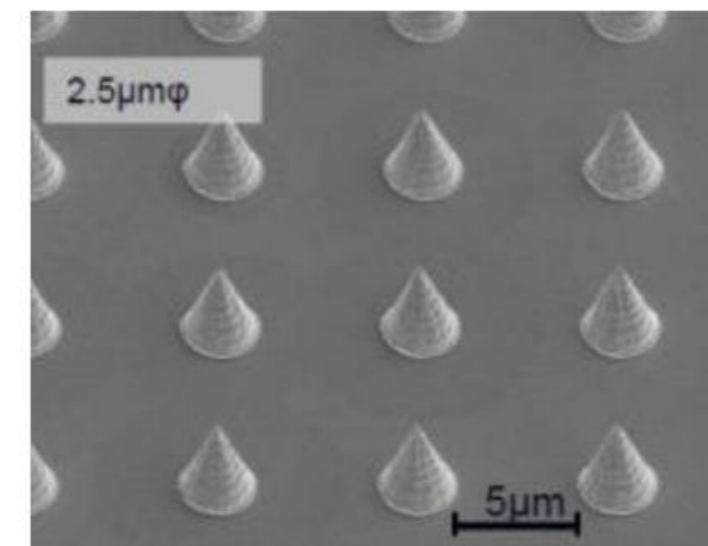
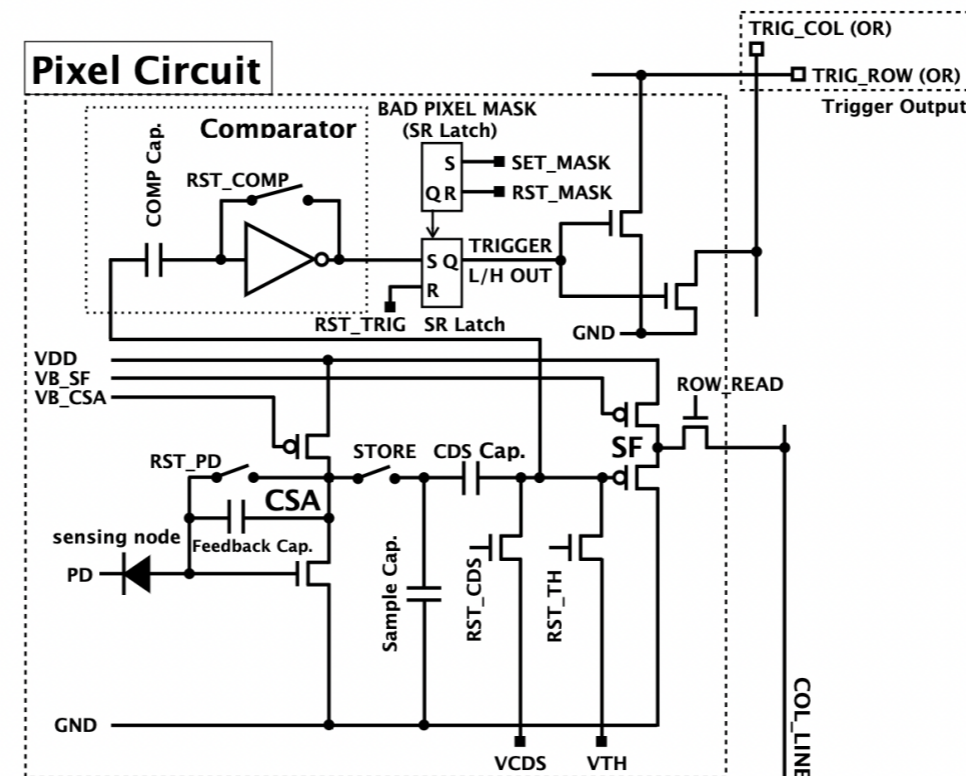
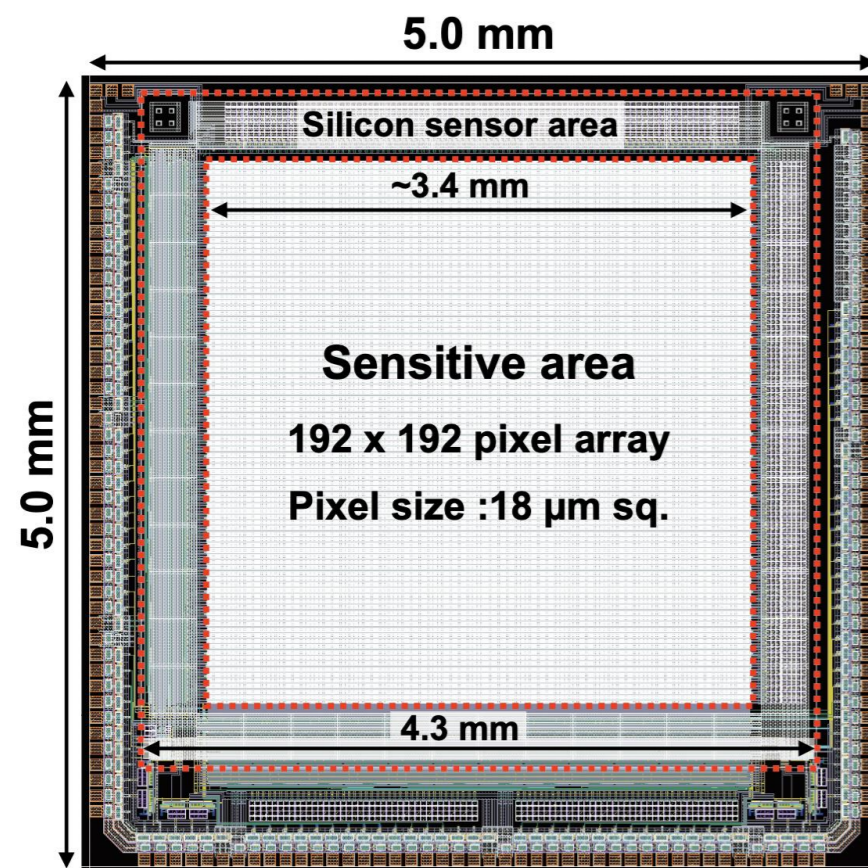


Hybrid pixel sensor  $\rightarrow$  Si sensor coupled to pixel ASIC with 18  $\mu\text{m}$  pixels



## Sensor information

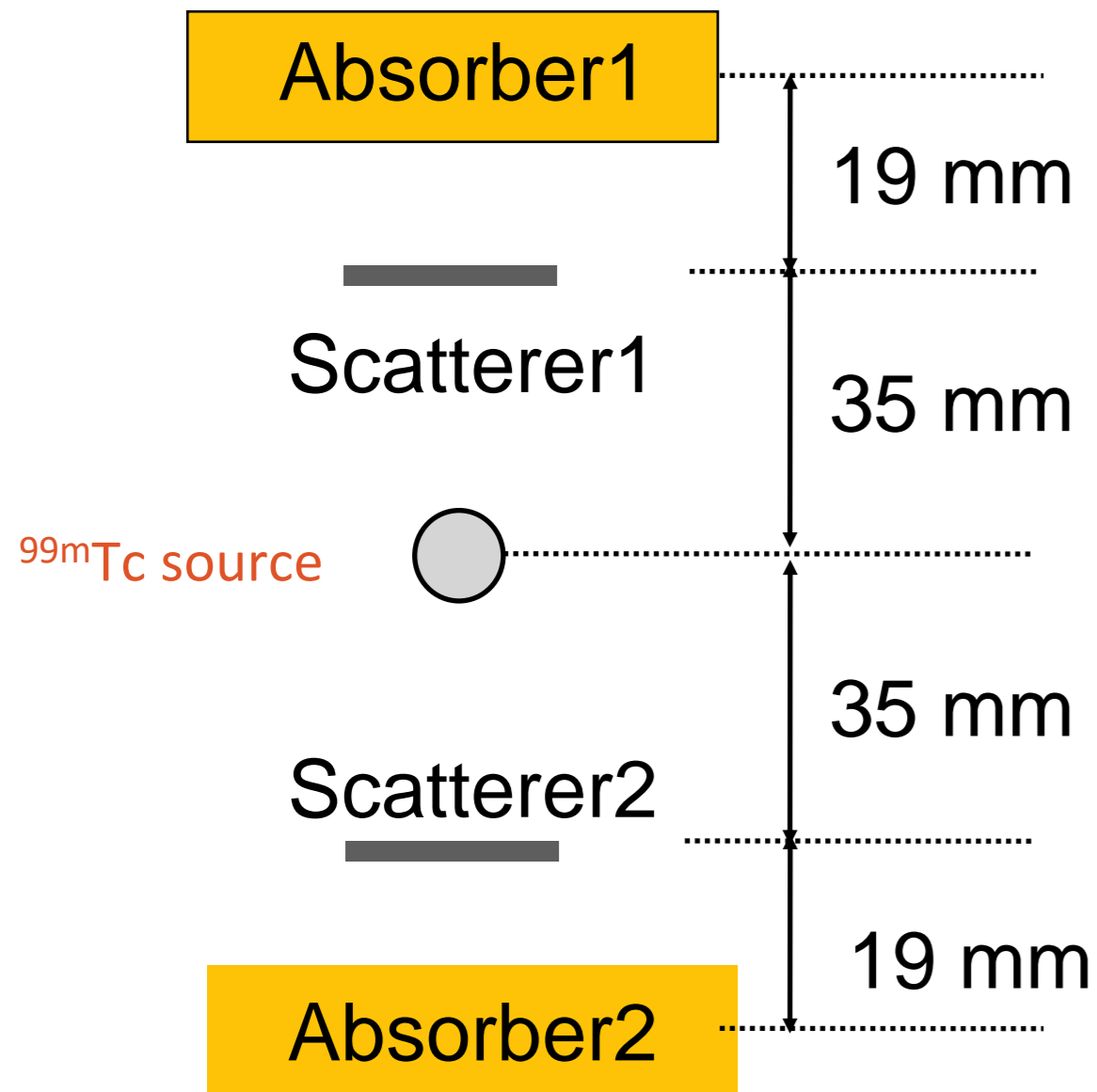
- Chip size (Si): 4.3 mm x 4.3 mm
- Sensor thickness: 450  $\mu\text{m}$
- ASIC size : 5.0 mm x 5.0 mm
- Pixel size : **18  $\mu\text{m}$  sq.**
- Pixel number: 192 x 192 (= ~233k)



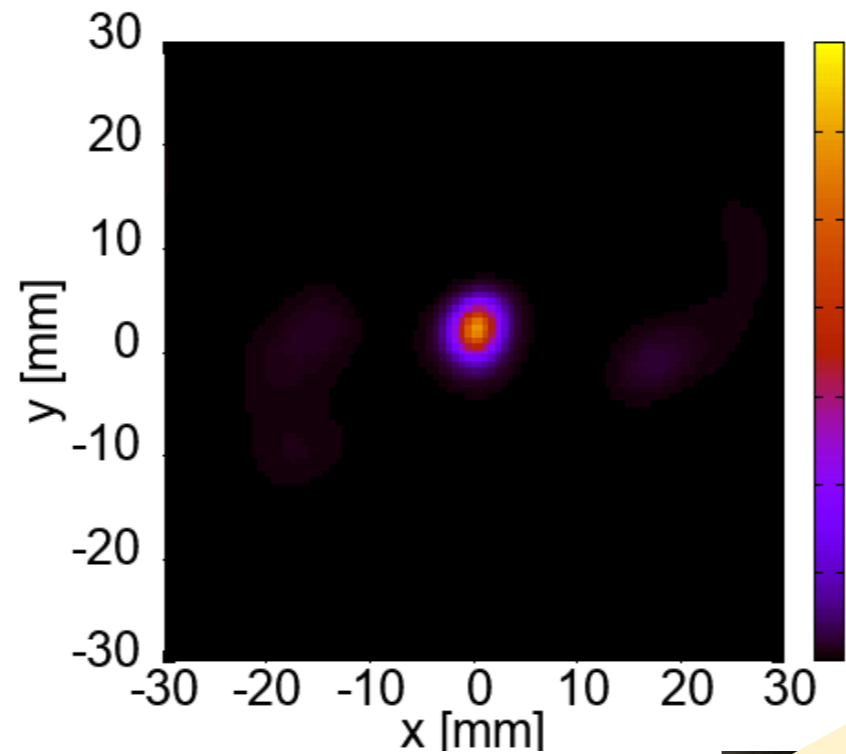
**Au Micro-bump**  
(Tohoku MicroTec Co., Ltd.)



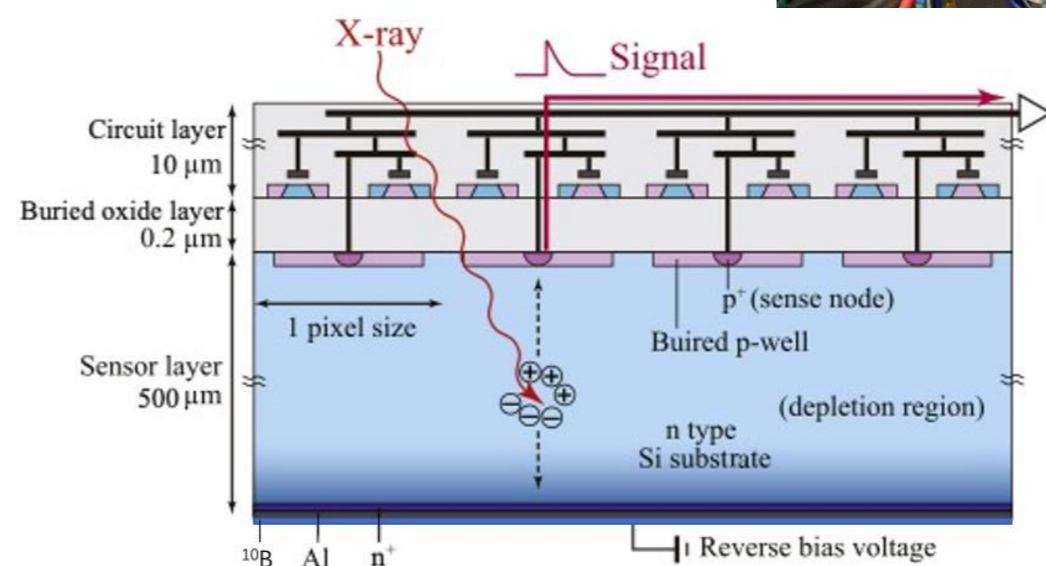
## Experimental Setup



## 140.5 keV Compton imaging



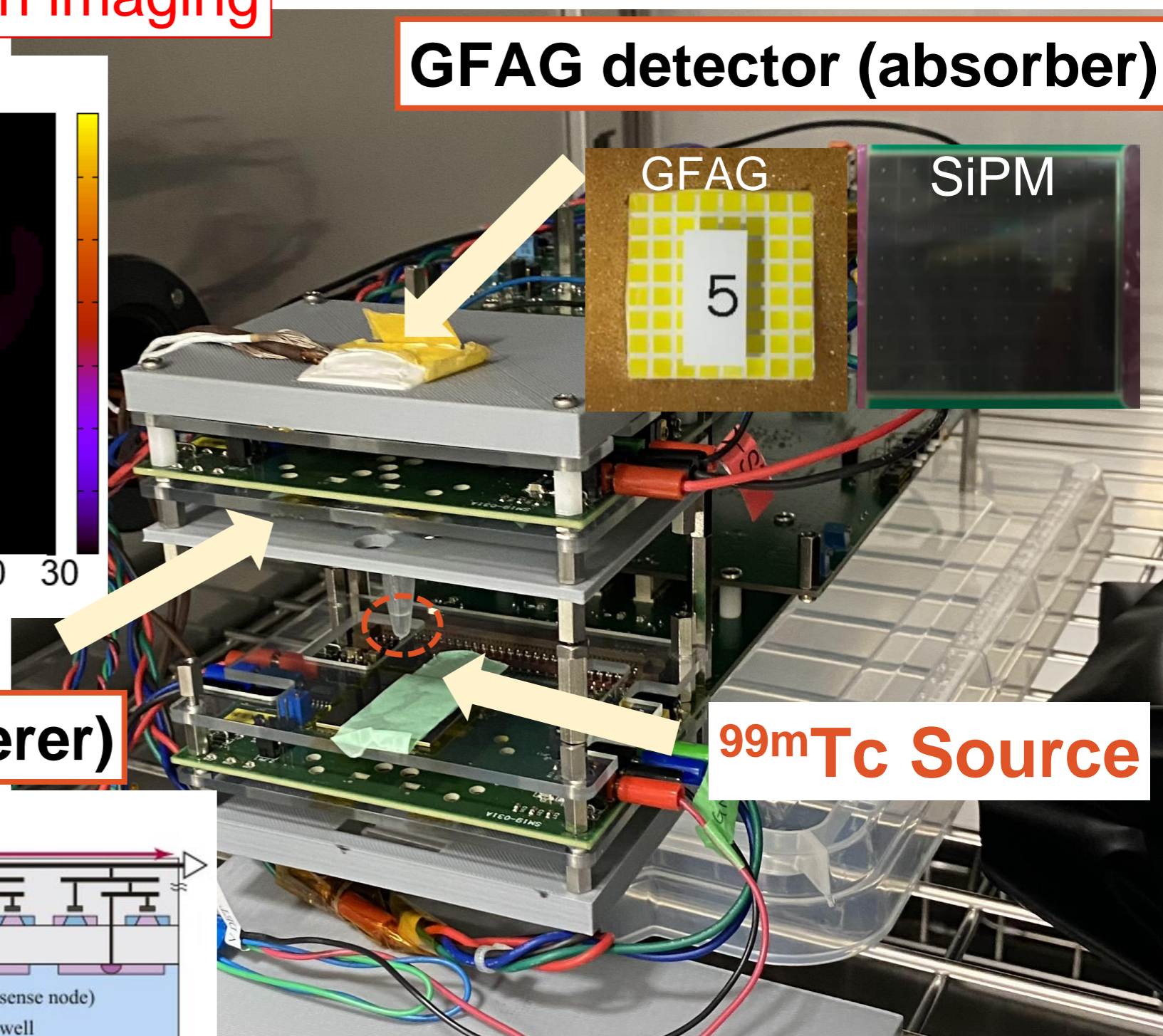
## XRPIX7 (scatterer)



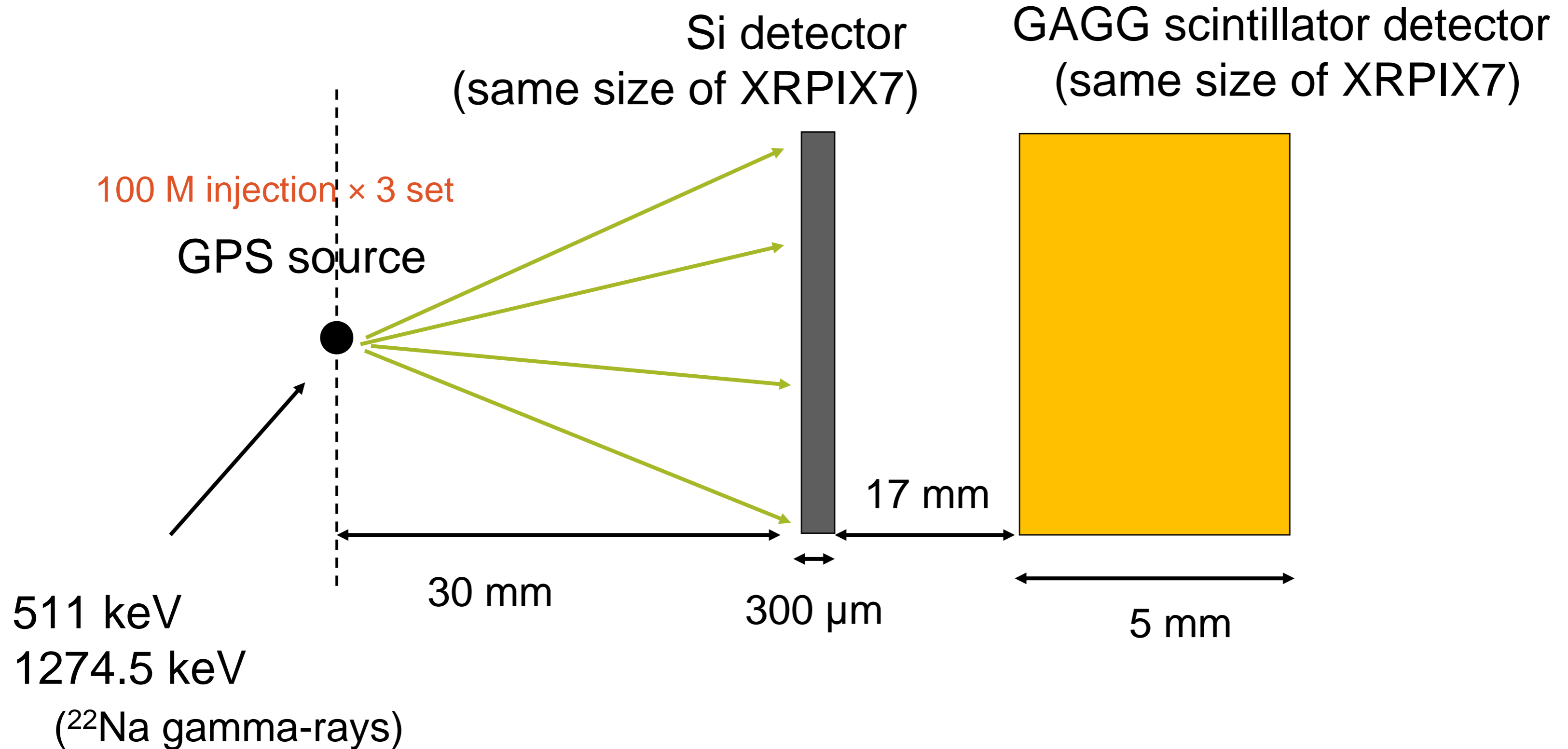
## GFAG detector (absorber)



## $^{99m}\text{Tc}$ Source



## Simulation setup





## Data format Si + GAGG Coincidence data

[event ID, track ID, parent ID, process name, detector name, deposit energy, step start position (x,y,z) [mm] , step end position (x,y,z) [mm], momentum direction (x,y,z), kinetic energy]

```

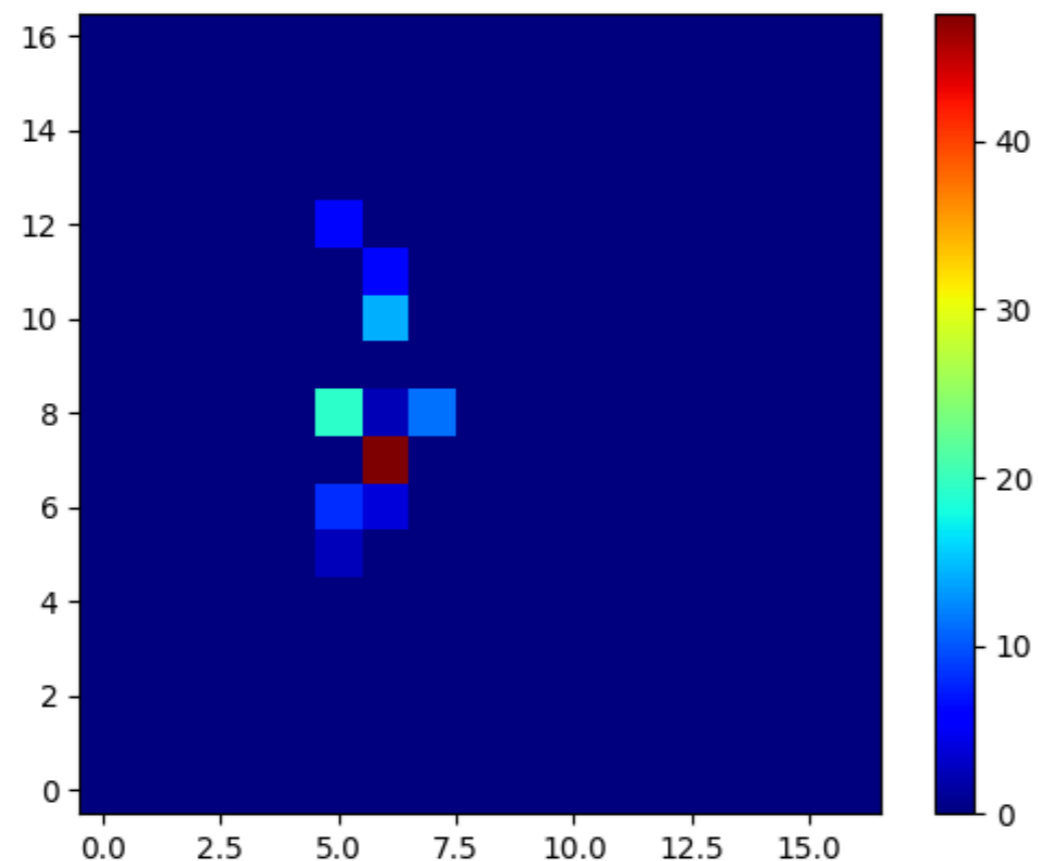
150787 1 0 gamma SiLogical compt 55.6403 30 -4.93426 5.16096 30.2006 -4.96725 5.19547 0.934857 0.334142 0.119965 455.36
150787 1 0 gamma GAGGLogical phot 455.36 47.3 1.14454 7.38974 50.3461 2.2333 7.78063 0.934857 0.334142 0.119965 0
150787 2 1 e- SiLogical eIoni 12.6608 30.2006 -4.96725 5.19547 30.2029 -4.97487 5.19648 -0.440073 -0.433698 0.786284 42.8708
150787 2 1 e- SiLogical eIoni 26.7524 30.2029 -4.97487 5.19648 30.2002 -4.97758 5.20139 0.792296 0.372711 0.483067 16.1184
150787 2 1 e- SiLogical eIoni 5.84556 30.2002 -4.97758 5.20139 30.201 -4.9772 5.20187 0.521554 0.178869 0.834258 10.2729
150787 2 1 e- SiLogical eIoni 4.14641 30.201 -4.9772 5.20187 30.2012 -4.97713 5.2022 0.760945 0.193592 -0.619262 6.12647
150787 2 1 e- SiLogical eIoni 2.47519 30.2012 -4.97713 5.2022 30.2013 -4.9771 5.20211 -0.499787 -0.342218 -0.795676 3.65128
150787 2 1 e- SiLogical eIoni 3.65128 30.2013 -4.9771 5.20211 30.2012 -4.97713 5.20204 -0.499787 -0.342218 -0.795676 0
    
```

$$\text{Recoil direction} = (x\_end, y\_end, z\_end) - (x\_start, y\_start, z\_start)$$

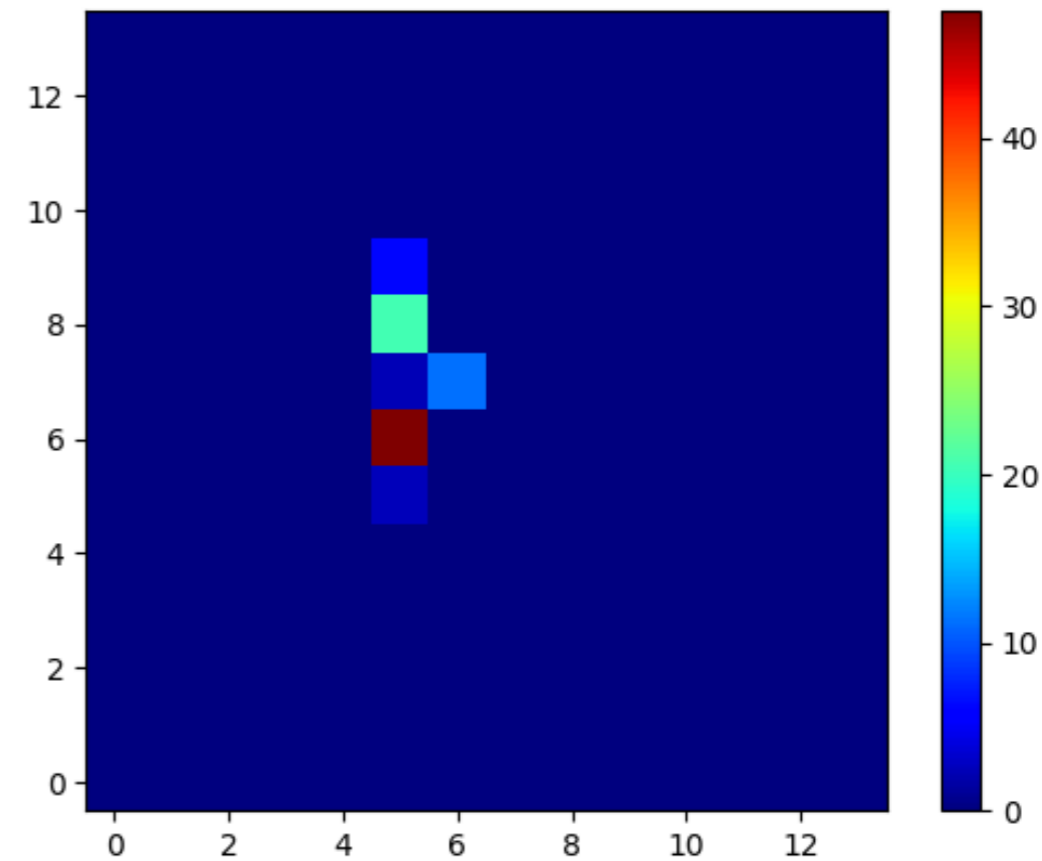


511 keV

18  $\mu\text{m}$  pixels



36  $\mu\text{m}$  pixels

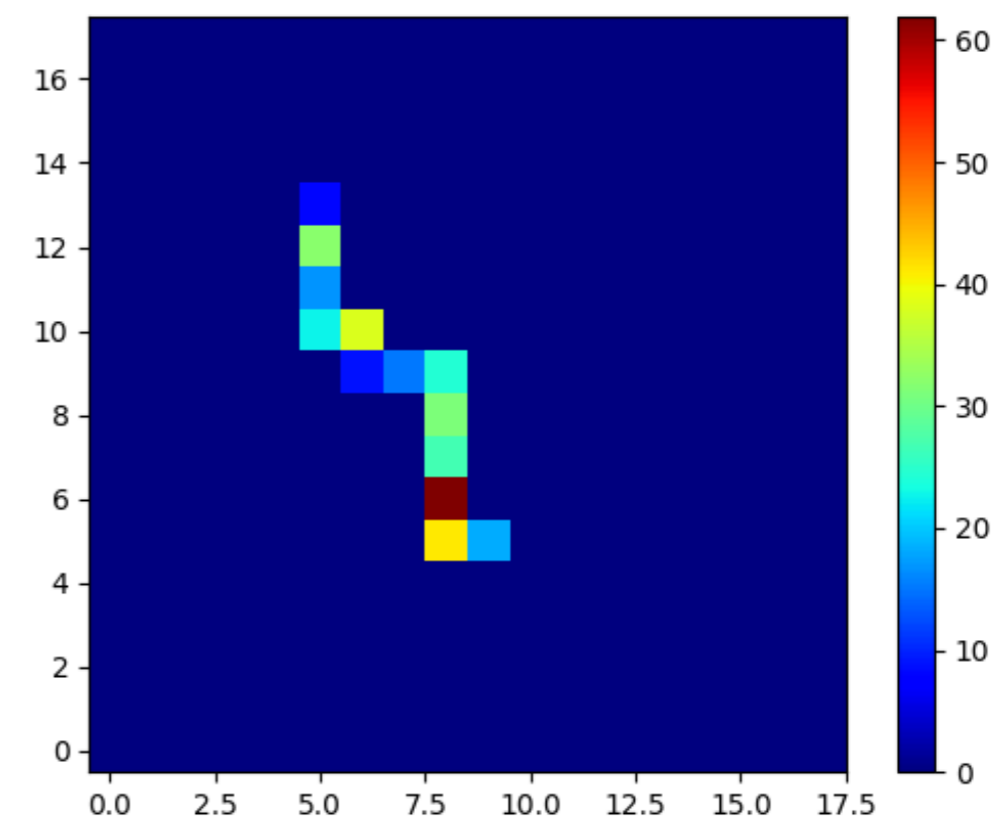
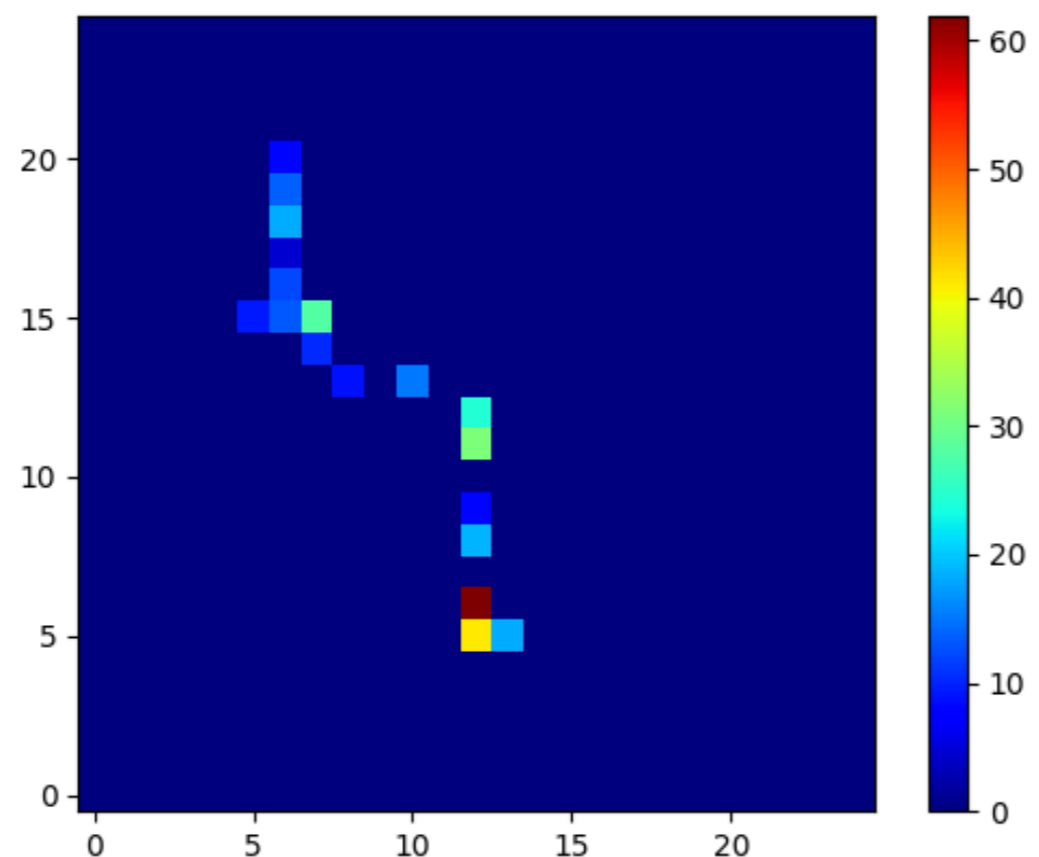


	Coincidence events	1-2 pixels event	3 < pixels event
18 $\mu\text{m}$ pixels	8166	3220	4946
36 $\mu\text{m}$ pixels		1564	6602

1274.5 keV

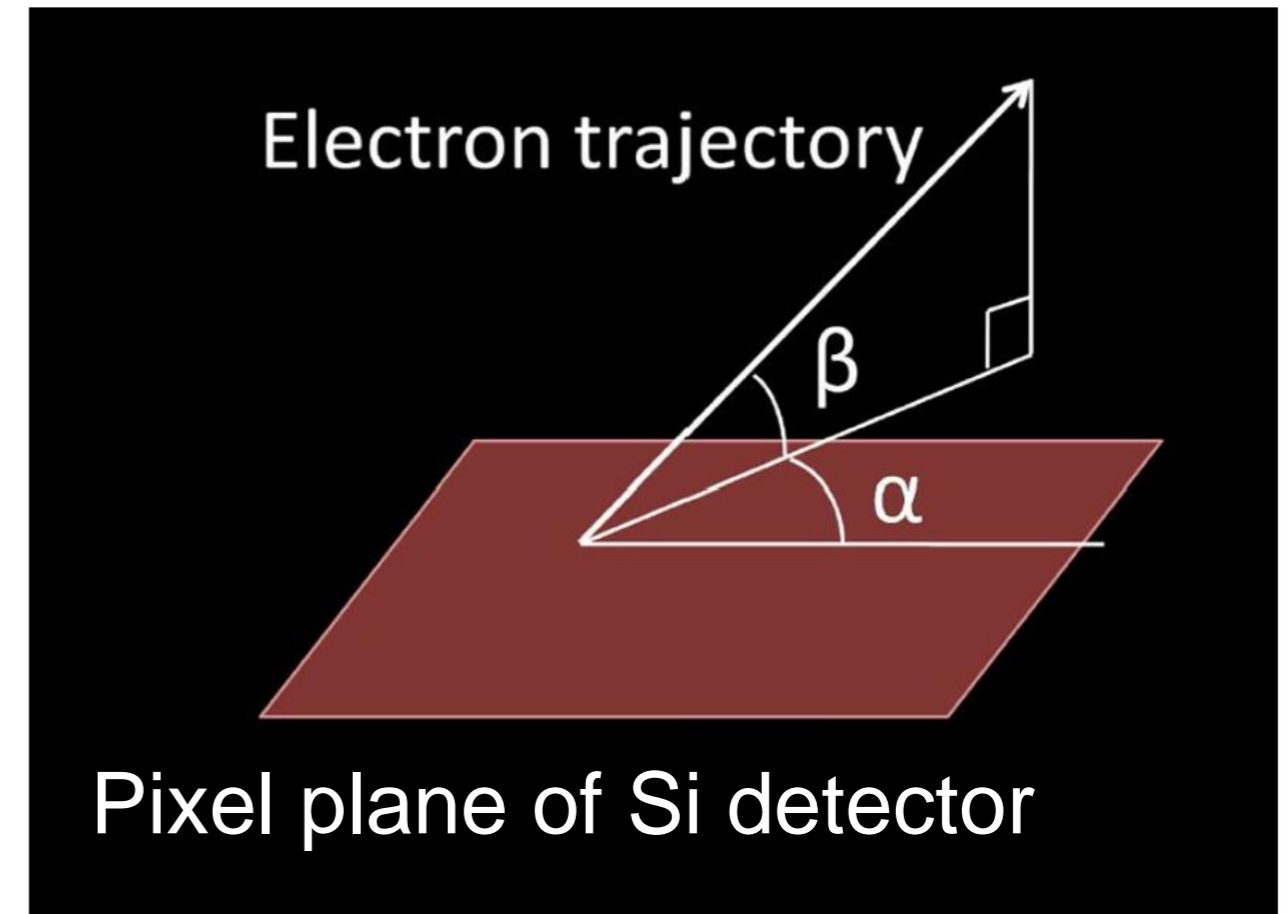
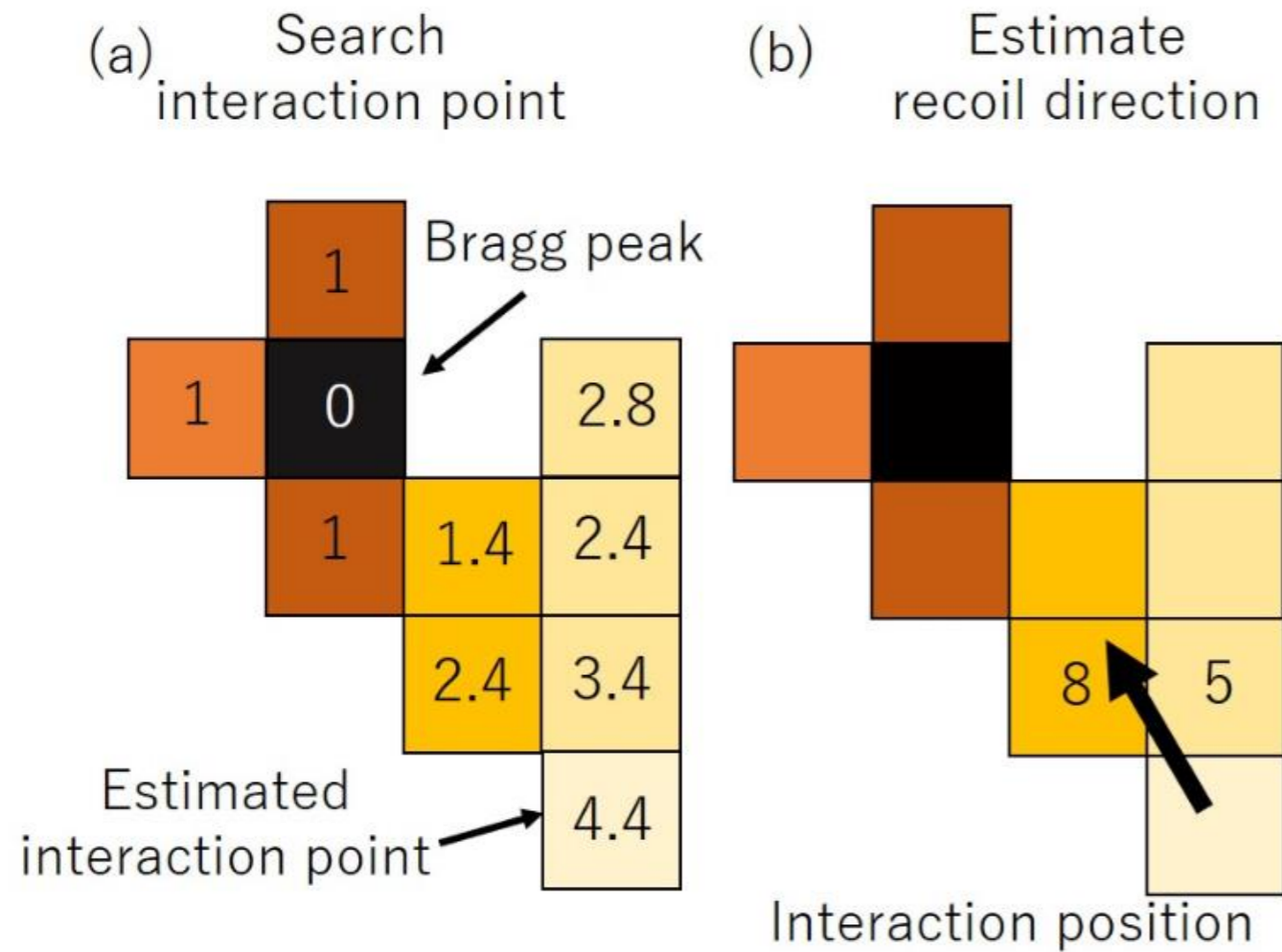
18  $\mu\text{m}$  pixels

36  $\mu\text{m}$  pixels



	Coincidence events	1-2 pixels event	3 < pixels event
18 $\mu\text{m}$ pixels	1886	71	1815
36 $\mu\text{m}$ pixels		16	1870

## Estimation method of $\alpha$ angle



Vector of the adjacent pixel from start pixel

$$\vec{x} = \frac{\sum_{i=1}^N w_i \vec{x}_i}{\sum_{i=1}^N w_i}$$

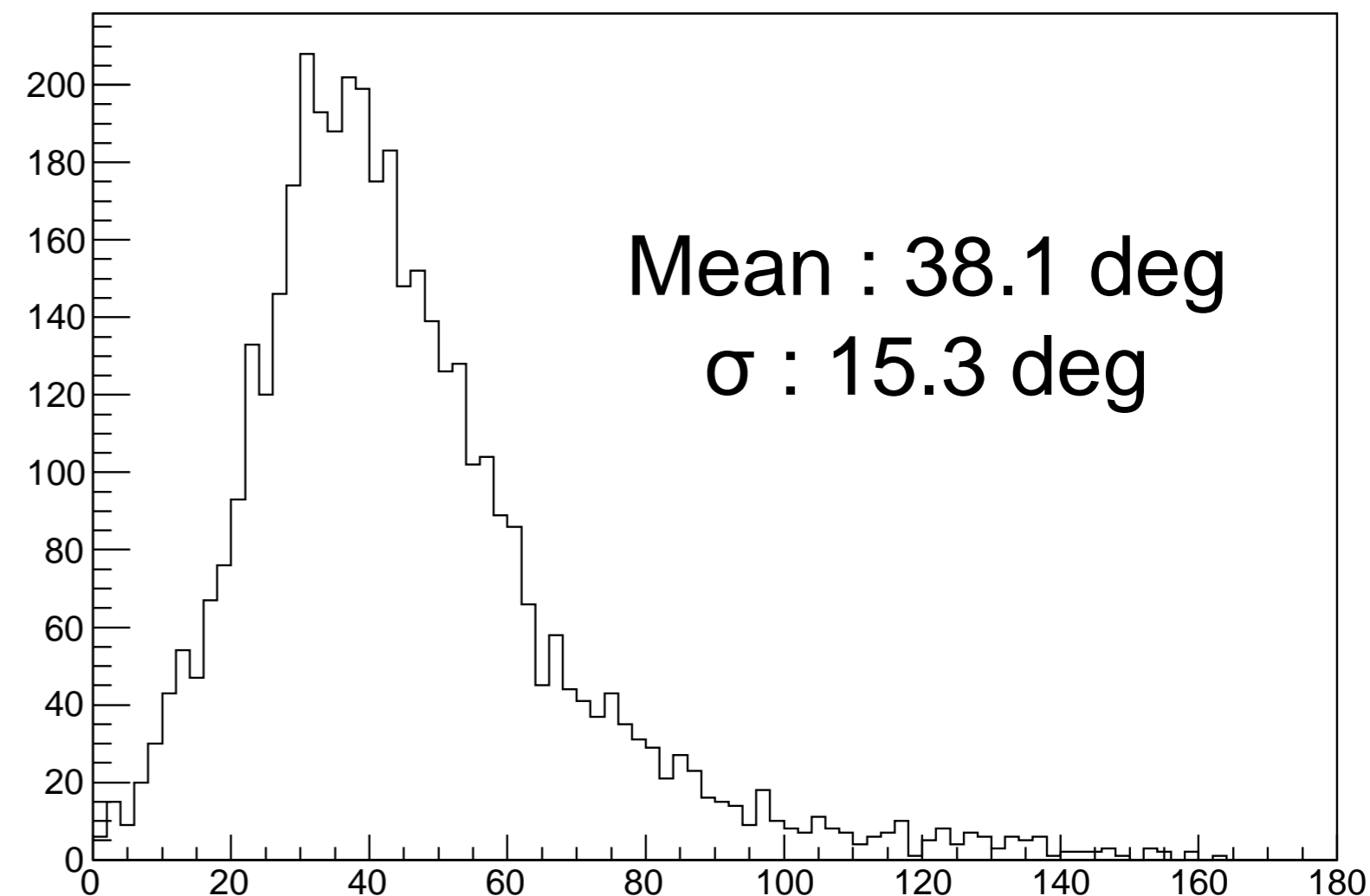
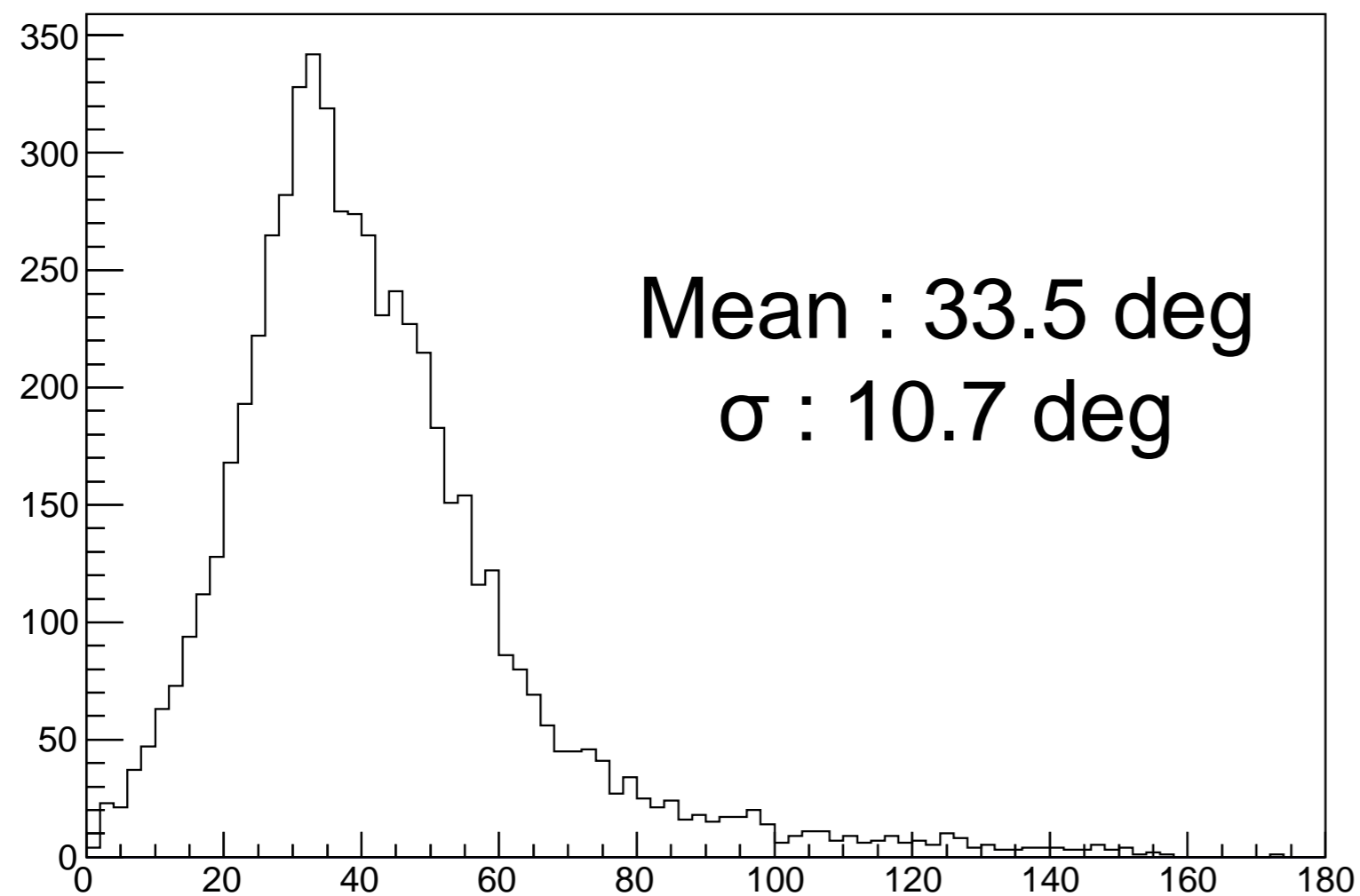
Deposited energy in a pixel



511 keV

18  $\mu\text{m}$  pixels

36  $\mu\text{m}$  pixels

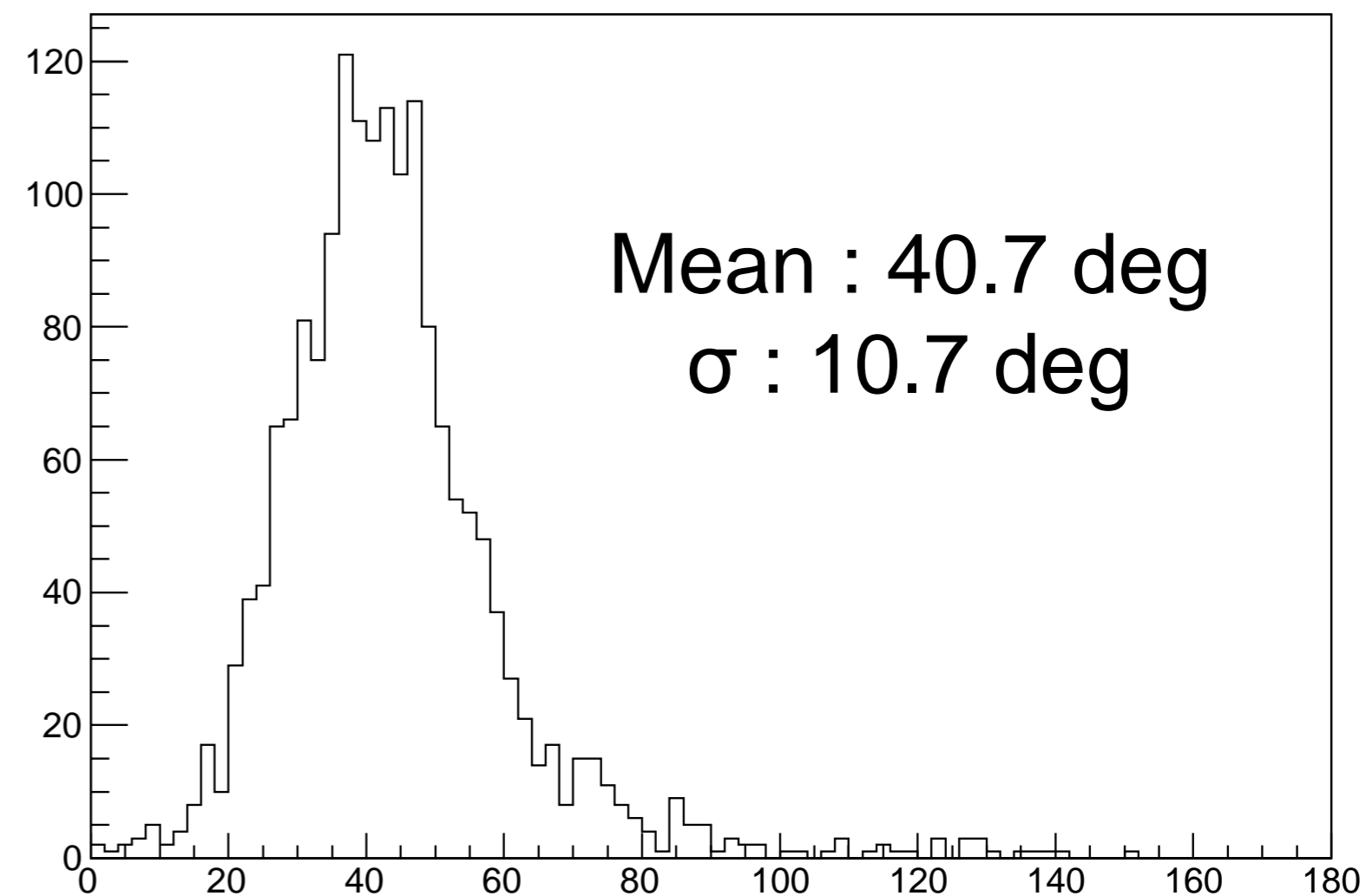
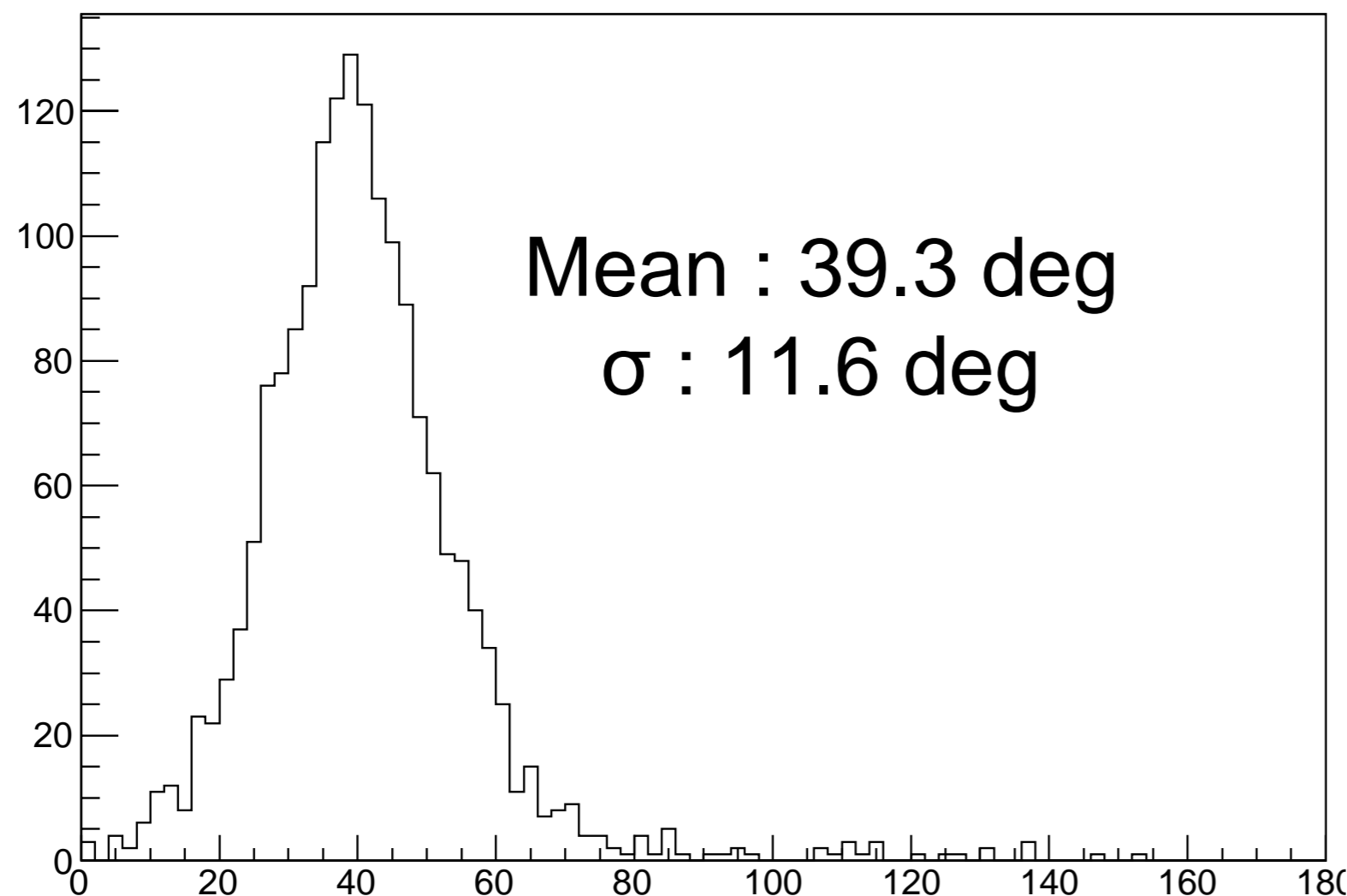


Difference of simulated and calculated  $\alpha$  angles [degree]

1274.5 keV

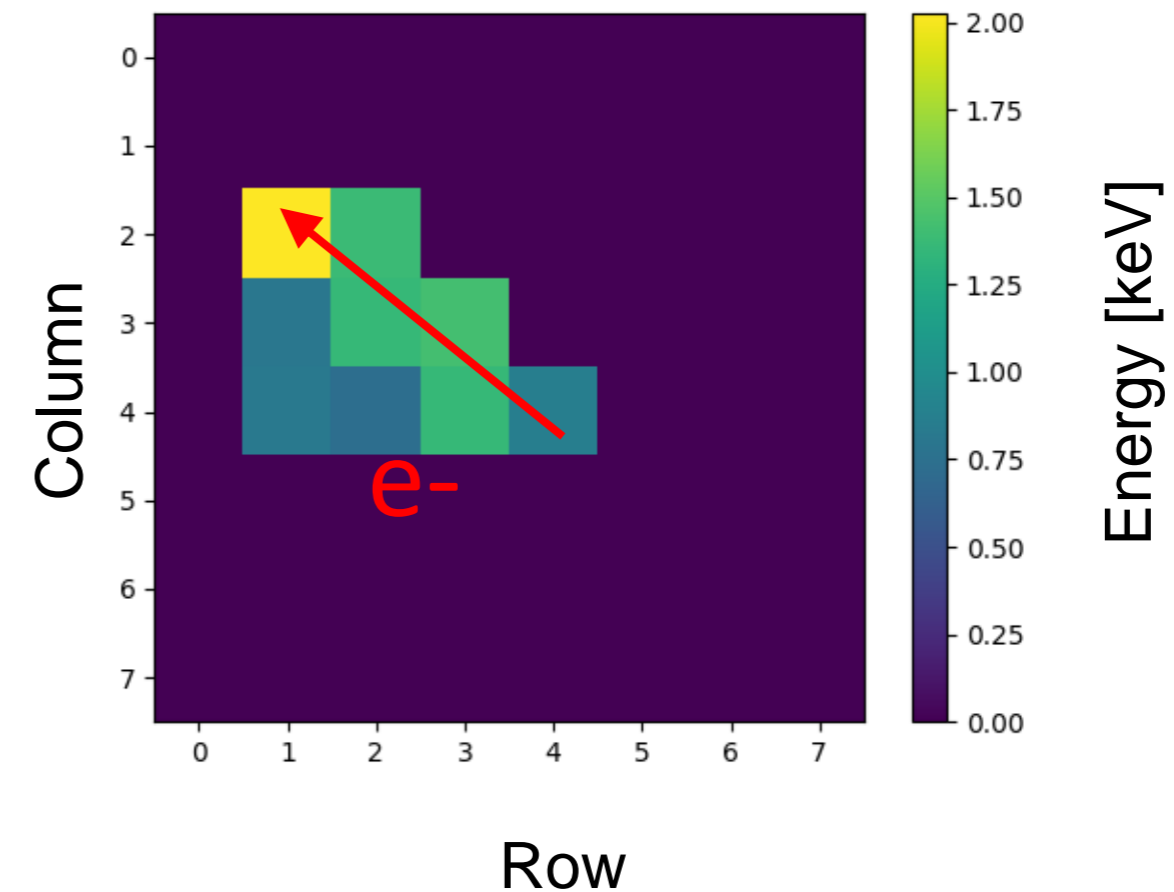
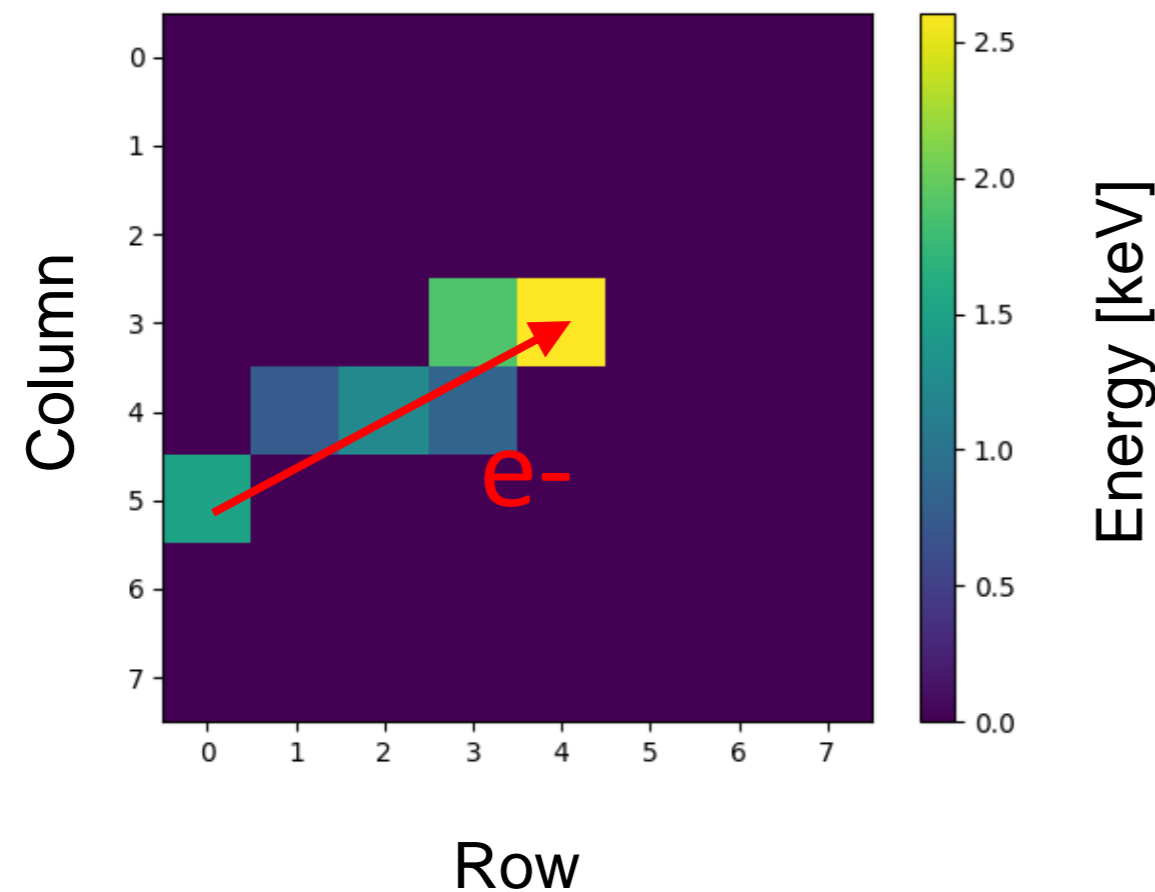
18  $\mu\text{m}$  pixels

36  $\mu\text{m}$  pixels



Difference of simulated and calculated  $\alpha$  angles [degree]

## Recoil electron trajectories of 511 keV gamma-ray ( $^{22}\text{Na}$ )



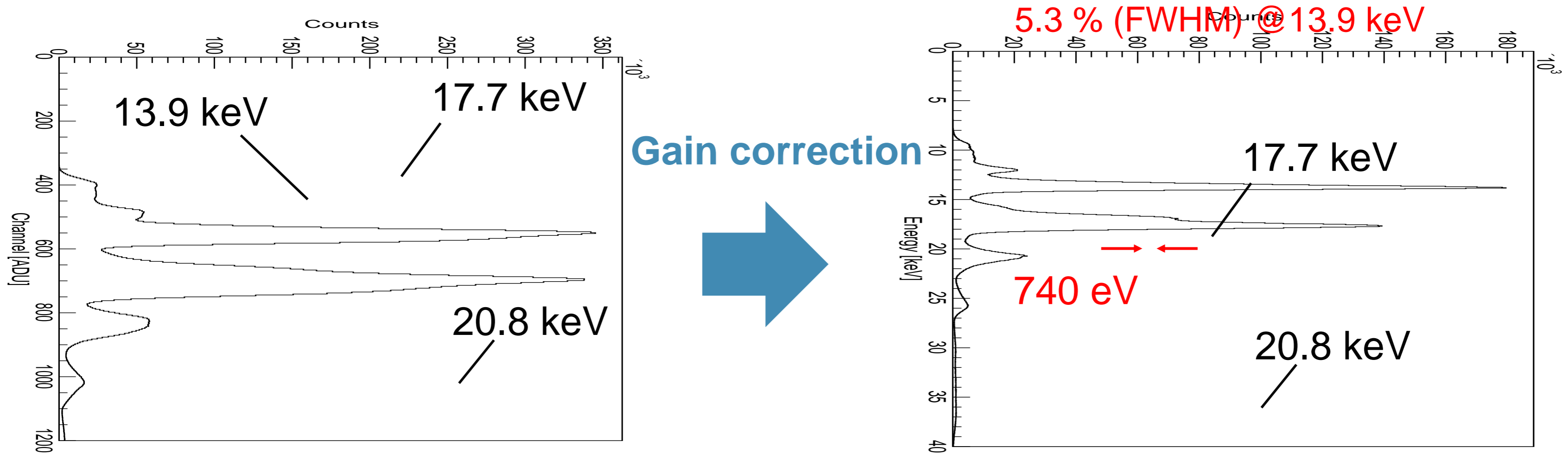
XRPIX7 could detect some of recoil electron trajectories of 511 keV gamma-ray. For future work, we need to establish the method to extract the correct electron trajectory because XRPIX7 can measure only 2D trajectory.



- We are developing SOI pixel detectors with pixel size of 36  $\mu\text{m}$
- We also developed Si-ASIC hybrid sensor with pixel size of 18  $\mu\text{m}$
- The Monte Carlo simulation by geant4 shows that the estimation accuracy of 2D recoil direction is not significantly improved by 18  $\mu\text{m}$  measurements compared to by 36  $\mu\text{m}$  measurements although the recoil trajectory can be measured more finely.
- The estimation method of 3D recoil direction (B.C Plimley, UC Berkeley Ph.D thesis, 2014) will be implemented
- XRPIX7 can detect a recoil electron trajectory of 511 keV gamma-ray (but not full depletion)

Thank you for your attention

## $^{241}\text{Am}$ spectrum of all pixels



- Temperature : 0 deg
- Vdet : -25V (not full depletion)